

## Radiation Sensors

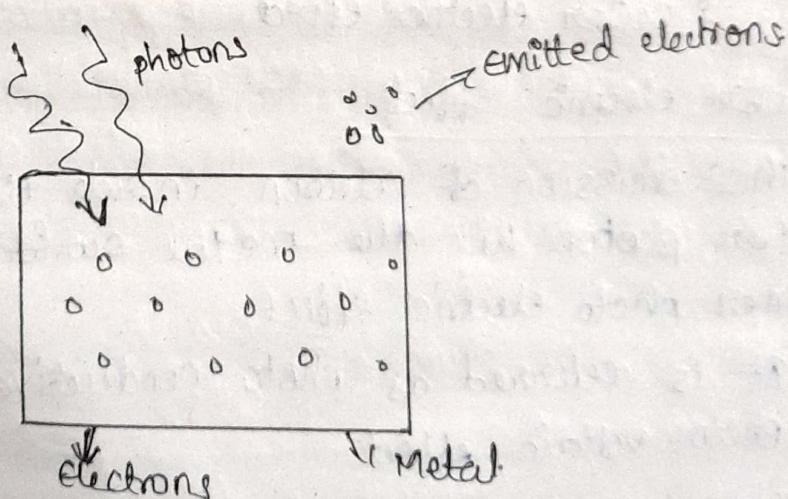
- ⇒ Radiation sensor is a device which convert incident radiation sig's into electrical output signals
- ⇒ Ex:- Electromagnetic, Neutrons, fast neutrons, electrons, & heavy charged particles

### Radiation sensor classification

- ⇒ There are mainly classified into three types

1. photo conductive cells
  - Ex:- light
2. photo emf cells.
  - Ex:- photovoltaic, barrier cell
3. photo electric cell.
  - Ex:- photo emissive.

### photoelectric effect



- ⇒ When a light is incident on the matter or metal, the electrons gets excited.
- ⇒ They come back to ground state emitted electrons on the surface. The phenomenon is known as photo electric effect. Electrons that are emitted in this process is called photo electrons.

→ Using Planck's equation the energy of a photon can be expressed as

$$E = h\nu$$

Let  $h = \text{Planck's constant} = 6.625 \times 10^{-34} \text{ J-sec}$

$\nu = \text{frequency of radiation (Hz)}$

⇒ The photon energy is must be equal to the energy of the electron emitted from the atom & the energy required to release the electron from the metal.

$$E = KE$$

$$E = \frac{1}{2}mv^2$$

$$\Rightarrow h\nu = \frac{1}{2}mv^2$$

### Types of photo electric effect

There are two types of PEE namely

1. Inner electric effect
2. Outer electric effect

### Inner electric effect

⇒ The emission of electron inside the material when photon hit the metal surface is called Inner photo electric effect

⇒ It is referred as photo conductive effect or photo voltaic effect

### Outer photo electric effect

⇒ The emission of electron outside material from the metal surface when photon hit the metal surface is called Outer photo electric effect.

⇒ It is referred as light sensitive resistor

# Basic characteristics of Radiation Sensors (8)

## photo detectors

1. working function
2. spectral sensitivity & spectral threshold.
3. static & dynamic response.
4. quantum yield & quantum voltage.
5. static fatigue & dynamic fatigue.
6. drift.
7. time lag.

### 1. working function

⇒ It is defined as minimum amount of energy required to emit an electron from a surface.

⇒ Mathematically it is expressed as

$$\phi = \frac{E}{e}$$

let  $E$  = photon energy  
 $e$  = charge of electron

⇒ It is totally depends on the nature of the metal  
 ⇒ Metallic elements with high atomic number has small working function. Hence they are used in fabrication

### 2. spectral sensitivity & spectral Threshold

⇒ spectral sensitivity is the relative efficiency of detection of light & wave length.  
 ⇒ spectral sensitivity is expressed in microampere.  
 ⇒ The condition for the electron to escape from the metal surface is given as:  $h\nu > \phi e$ .  
 ⇒ The above equation assume the velocity of the electron in photon energy is zero.

⇒ Threshold (or) critical frequency is the minimum frequency of the incident radiation to start the photo electric effect is expressed as.

$$V_0 \geq \frac{\phi_e}{h}$$

⇒ And threshold wavelength is expressed as.

$$\lambda_0 \leq \frac{hc}{\phi_e}$$

### 3. Static & dynamic response.

⇒ The ratio of the output to the input for static illumination is called static response.

⇒ Mathematically it is expressed as.

$$S_{st} = \frac{i_a}{\phi_e}$$

Let  $i_a$  = anode current

$\phi_e$  = light flux incident

⇒ The ratio of the change in the output to the corresponding change in the input for dynamic illumination is called dynamic response.

⇒ Mathematically it is expressed as.

$$S_{dynamic} = \frac{di_a}{d\phi_e}$$

$$S_{dynamic} = \frac{di_a}{dt} / \frac{d\phi_e}{dt}$$

### 4. Time lag

⇒ It is defined as the time interval between the incidence of light on metals & emission of electrons.

S.NO Photo Sensors

1. photo emissive cells	$10^{-8}$ sec.
2. light sensitive resistors	$5 \times 10^{-2}$ sec.
3. gas filled photo cells	$10^{-5}$ sec.

⇒ The time response characteristics of the photo sensor can be obtained from the below relation

$$y = y_0 (1 - e^{-at})$$

Let  $y_0 = \text{constant}$

5. Quantum yield of quantum voltage

⇒ It is defined as the ratio of number of electrons emitted to the number of electrons ( $\phi$ ) photons received.

$$\text{If } \Rightarrow \frac{\text{no. of electrons emitted}}{\text{no. of electrons} (\phi) \text{ photons received}}$$

⇒ Energy required to free an electron. is given as

$$\epsilon_\lambda = \frac{1.2395}{\phi} (\text{eV})$$

⇒ When the light strikes the metal surface it emits electrons with some energy. such process is called photo electric effect; that time obtain some voltage. is called as quantum voltage

⇒ The maximum kinetic energy that an electron contain after emitting from the metal surface. is expressed as.

$$E_m = \epsilon_\lambda - \phi$$

$$E_m = \epsilon_\lambda - \frac{hv}{e}$$

$\Rightarrow$  Maximum kinetic energy,  $e_m$  provides the electron velocity for which the photo electron travels in the perpendicular direction. Therefore,  $v_m = 0$ .

$$E_\lambda = \frac{hv}{e}$$

### 6. Static fatigue or dynamic fatigue (damage to materials)

$\Rightarrow$  When a light strikes the metal surface with high energy, the detector response will not be correspondent with that of the input.

$\Rightarrow$  It appears mostly photovoltaic cells.

$\Rightarrow$  When the light strikes the metal surface fluctuates over 100 Hz frequency, the detector response in many cases will be something than it supposed to be.

$\Rightarrow$  It is mostly appears in the LED.

### 7. Drift

$\Rightarrow$  It is defined as the suddenly change in the response over a span period of time after that the cell exposed to radiation.

## Photo Resistors / photo detectors

There are of three types. They are.

### 1. photo emissive cells

$\Rightarrow$  Vacuum type photo emissive cells

$\Rightarrow$  Gas filled photo emissive cells

### 2. photo multiplier

### 3. photo conductive cells

## i. photo emissive cells

→ photo emissive cells consisting glass tube filled with vacuum and a pair of electrodes such as cathode, Anode.

→ photo emissive cell is a device which converts light energy into electrical energy

→ According to the figure cathode is semi cylindrical & coated with light sensitive metal & anode is round circle.

→ These two electrodes are placed inside a glass tube

→ when the light strikes the coated surface of the cathode photo electrons are emitted & are attracted by anode. As a result generates a small photo electric current in the circuit

→ The flow of photo electric current in the circuit can be determined by connecting a resistor & battery source.

→ The photo electric current depends on the incident of radiation & anode to cathode voltage.

### Types of photo emissive cells

#### i) vacuum type photo emissive cell

→ In this cell having glass tube.

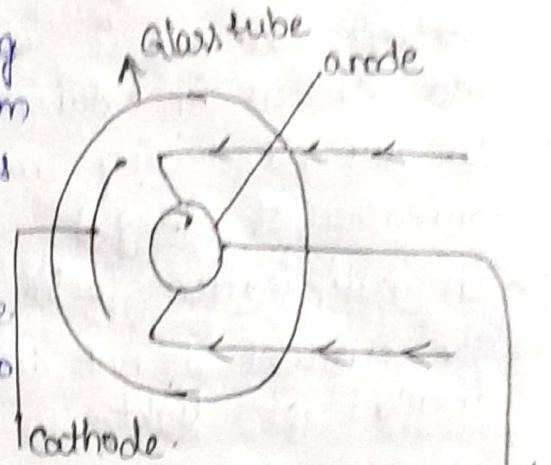
→ When the is incident on the coated surface of the cathode the electrons are emitted & attracted by anode producing photo electric current flowing in the circuit.

→ The current is directly proportional to the incident of light & Incident of radiation

→ These types of cells used in Television & photometry

#### ii) gas filled photo emissive cell

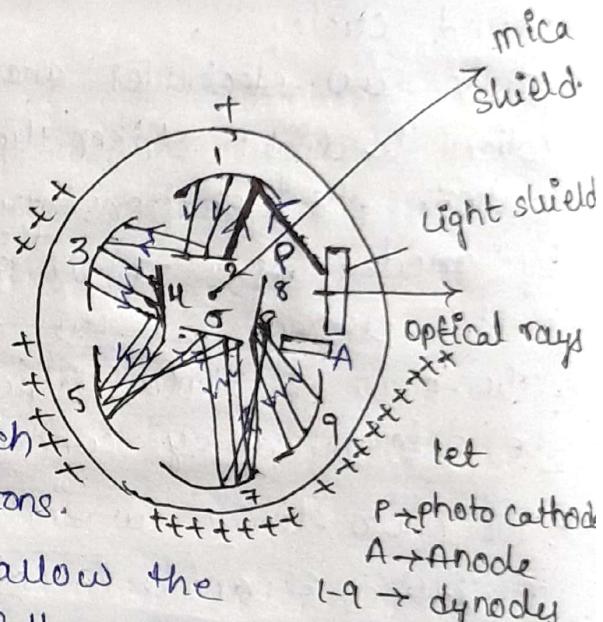
→ In this cell consisting glass tube filled with the gas at low pressure.



- ⇒ When the voltage is applied b/w cathode & anode exceed the critical value, and it accelerates photo electrons, the gas is ionized by the photo electron into electron & cation.
- ⇒ In this cell having more output current due to ionization of the gas
- ⇒ Multiplication factor called gas factor is  $> 10$
- ⇒ The current is not directly proportional to the incident of light.
- ⇒ They are used in cinematography like recording.

## Q. photo multiplier; Inv

- ⇒ According to the figure, Photo multiplier consisting
- \* Mica shield
- \* Light shield
- \* Anode
- \* Cathode
- \* Dynodes



- ⇒ A Multiplier is a device which converts electrons into photons.
- ⇒ Light shield :- It is used to allow the optical rays to fall on the photo cathode.
- ⇒ Mica shield :- It is placed b/w photo cathode & dynodes to provide better isolation & block the emission of electrons.
- ⇒ photo cathode : It is an electrode used to generate photo electrons when a light fall on it
- ⇒ Anode : It is a electrode which attract the emitted (1) generated electrons from the dynode & generate all currents.
- ⇒ Dynodes : It is a electrode placed at higher potential. serially inside the glass tube. They are attracted photo electrons from the photo cathode.

## Working

- ⇒ When light is struck the surface are photo cathode it emits electrons called primary electron.
- ⇒ This electron will move towards dynodes & generates secondary electrons then the electron generated at dynode - 1 are moving towards dynode 2.
- ⇒ In this manner the electrons are moved towards all the dynodes generates a large stream of electrons at the anode. Similarly the electron at the anode generates the large output current is expressed as.

$$I = I_p k^n$$

Let  $I_p$  = Initial primary current

$k$  = Dynode emission co-efficient

$n$  = number of dynode stage.

- ⇒ Sensitivity of the photomultiplier is expressed as

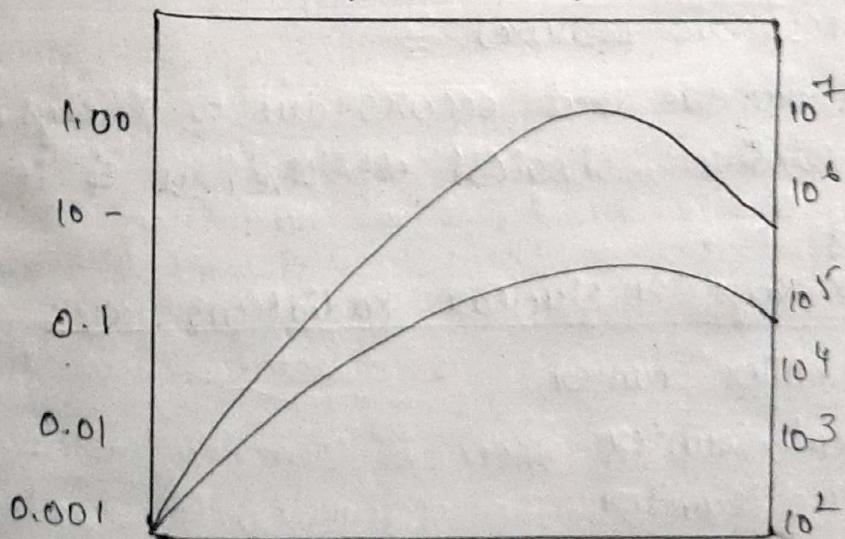
$$S = k_s v^{n/2}$$

Let  $k_s$  = constant

$v$  = Voltage for dynode pair.

$n$  = No. of dynode stages.

- ⇒ The current sensitivity / amplification characteristics of photo multiplier for various dynodes voltage is shown in below figure.



### 3. photo conductive cells

- ⇒ When an intrinsic semiconductor is exposed to external light source, the electrons present in it gets excited & jump from the conduction band.
- ⇒ The electrons generates holes in the valency band, leading to the formation of (EHP) Electron Hole pair in the semiconductor.
- ⇒ As a result, the concentration of recharge carriers increase thereby conductivity, the phenomena is called as photo conductivity. The device exist this phenomena is known as photo conductive cell.

### Note:

The change in conductivity of electrons, when the semiconductor metal is subjected to incident of light or radiation is known as photo conductive effect.

### X-Rays & Nuclear Radiation Sensors

- ⇒ They are having high energy radiations compared to optical range of radiation & have different units of measurement for their energy content at different parameters
- ⇒ For ex. ROENTGEN is a measure Intensity of radiation & it is define the charge for pressure (0 to 1 atmospheric pressure)
- ⇒ Radiation damage that occurs due to X-rays,  $\gamma$ -rays is called relative biological effectiveness & it is denoted by "R".

### Types of X-Rays & Nuclear Radiations are:

1. Geiger - muller Counter
2. proportional Counter
3. scintillation counter
4. Ionisation chamber.
5. Electron multiplier tube
6. Non-dispersive detectors.

⇒ The nuclear radiations from radionuclides are.

1. alpha particles
2. Beta particles
3.  $\gamma$  - Ray.

⇒ There are ionisation radiations apart neutrons. e.g.

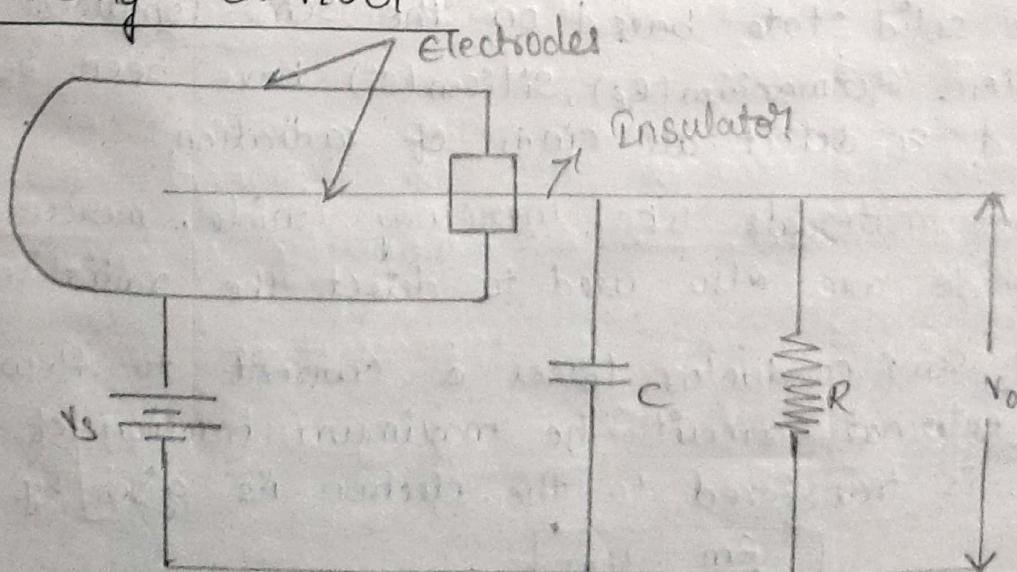
X-Rays are

1. ultra violet radiation optical types

2. extremely low frequency, radio frequency, microwaves.

S.No	Ionising radiation	Characterisation.	Detectors.
1.	$\alpha$ - particle	positively charged, highly ionising, low penetration discrete energy levels	Ionising chamber, proportional counter, scintillation counter
2.	$\beta$ - particle	More penetration than $\alpha$ - particle & continuous energy	Geiger Muller counter, proportional counter & scintilla- tion counter.
3.	$\gamma$ -Rays, X-Rays.	Penetrating electro magnetic types.	Geiger Muller counter, proportional counter.
4.	Neutrons	Indirectly ionising	Semi-conductor diode.

### 1. Ionising chamber



⇒ According to the figure the ionisation chamber is also called gas filled chamber is designed by central electrode is kept separated from the chamber which is also an electrode by an insulator.

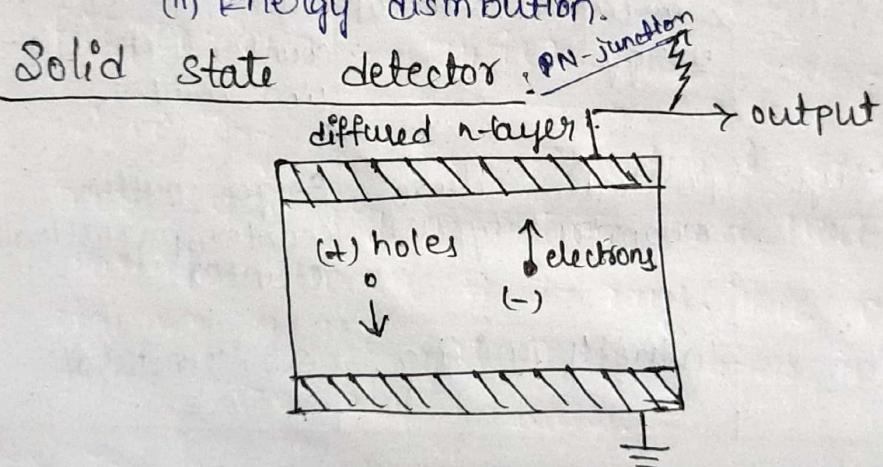
⇒ A supply voltage or no load voltage impressed between the resistance "R" in parallel with capacitor

$$V_0 = \frac{Q}{C}$$

⇒ The charge "c" resulting the emission of three types of ions in the chamber there are electrons, positive ions, negative ions.

⇒ For large specific ionisation, pulse type measurement is made with an information

- (i) Number of ionising particles
- (ii) Time interval between incidence
- (iii) Energy distribution.



⇒ The solid state based on the semi-conductor based detection. Germanium (Ge), Silicon (Si) have been best suited to detect all kinds of radiation.

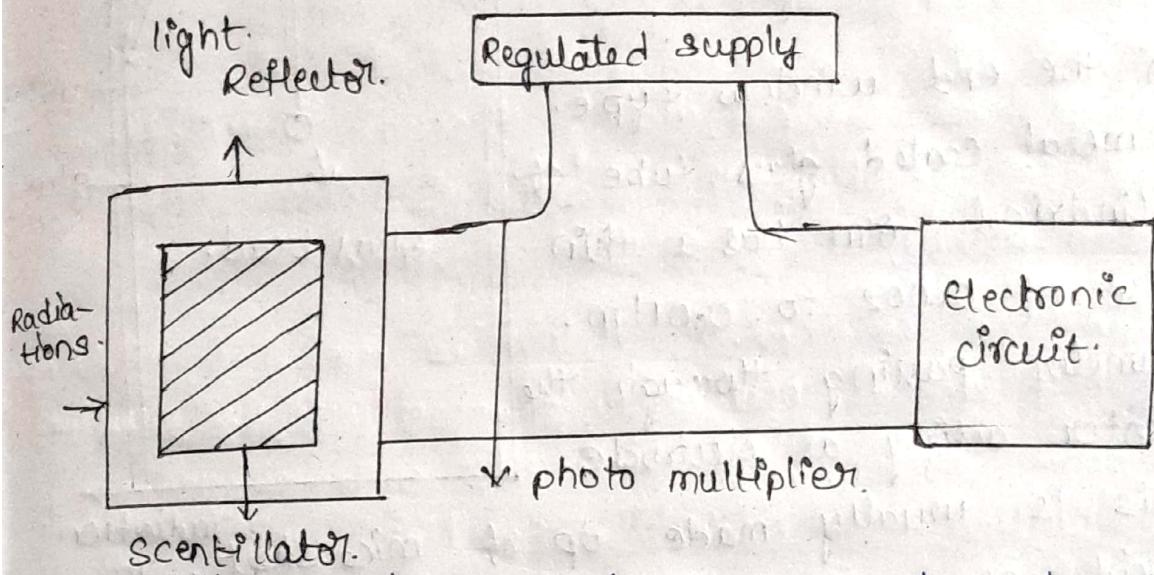
⇒ Other materials like mercury ionide, mercury Sulphide are also used to detect the radiation.

⇒ The semi conductor forces a current to flow in the external circuit. The maximum fraction of energy that is transferred to the electron is given by.

$$\frac{E_m}{E} = 4m$$

Let  $E_m$  = maximum energy transferred  
 $E$  = energy of ionising particles  
 $m$  = electron to particle mass ratio.

## Scintillation detector:



⇒ Scintillation of the flash are very short duration light pulses produced when a single crystal of organic material once activate electronic circuit when they receive higher energy radiation & This materials of scintillators

⇒ These detectors basically consists of a scintillator, a photo multiplier that converts light pulses into electrical pulses.

⇒ If the radiation energy received by the crystal is 'E', The no. of photo electrons produced is 'n' & is given by.

$$n = k_1 k_2 E$$

$$k_2 = f_1 f_2 f_3 f_4$$

## Geiger Muller counter.

⇒ It is the most commonly used gas filled counter named as geiger muller counter (a) Gm counter. it can measure all types of radiations with high sensitivity & high output. there are widely three types of Geiger muller (Gm) counter.

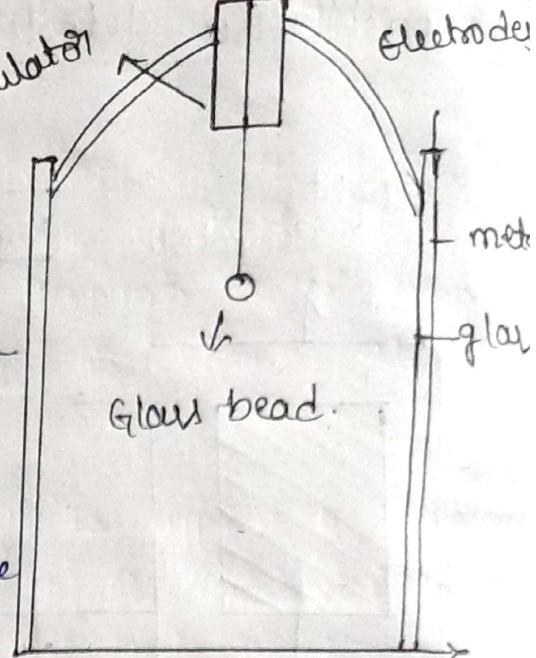
1. The end-window type

2. The cylindrical type

3. The needle type.

⇒ In the end window type.

a metal coated glass tube of cylindrical form has a thin wire of 0.002 to 0.011 m. diameter passing through the center acting as electrode.



⇒ This is usually made up of mica sheet. To avoid spark over the central electrode it terminates into a glass bead & radiation received by the end window.

### Proportional counter

⇒ According to the proportional counter they are more sensitivity in nature and used for  $\alpha$ ,  $\beta$  particles sources &  $\gamma$ -rays. They are also gas-filled chamber & the gas multiplication increases the pulse size also increases.

⇒ The gas multiplication changes between  $10^3$  &  $10^4$  to around  $10^5$ .

⇒ From the counter chamber designed data, applied field, pressure, mobility of ions.

⇒ The pulse size is expressed as.

$$V_p(t) = \frac{-n_0 e}{c} \left[ -\ln \frac{(d\phi/dn)}{(d\phi/dc)} + \ln \frac{(d\phi/dp)}{(d\phi/db)} \right]$$

$$V_p(t) = \frac{-n_0 e}{c} \left[ \ln \frac{(d\phi/dc)}{(d\phi/dc)} \right]$$

Let,

$d_o$  - dia of outer electrode.

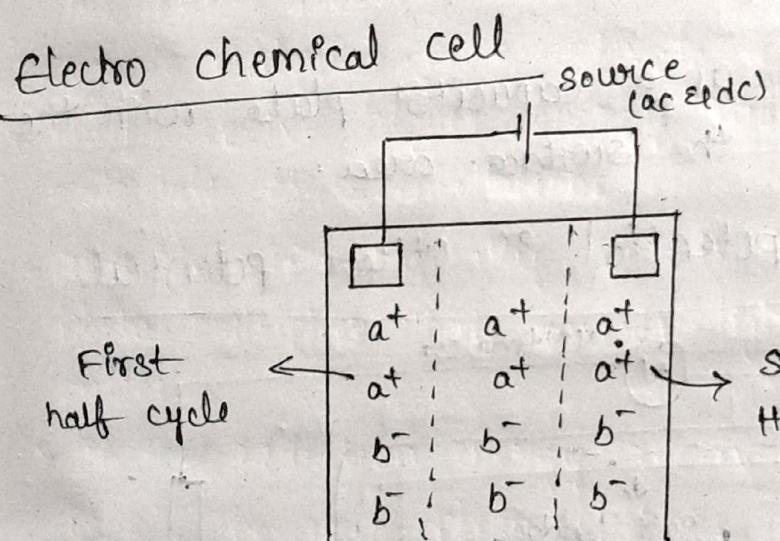
$d_c$  - dia of collecting electrode.

$d_p$  - distance of positive ion from central axis.

$d_n$  - distance of negative ion from central axis.

c - chamber of capacitance.

m - no. of pair pairs produced.



⇒ The electro chemical cell is mainly made up of two electrodes (cathode & anode) and an electrolyte. The two electrodes are dipped in the electrolyte connected to metal conductors.

⇒ An electro chemical cell is a combination of two equivalent half cycles. It has same electrodes but may have different electrolyte.

⇒ According to the figure

\* The anode & its electrolyte concentration are shown on the left side

\* The cathode & its electrolyte concentration are shown on the right side.

\* The vertical imaginary line boundary.

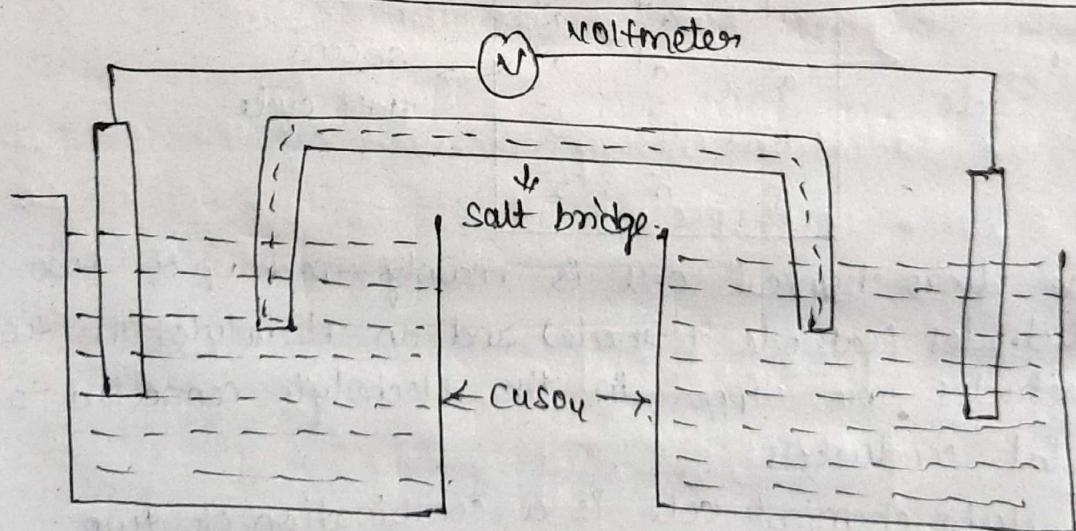
## Working

- ⇒ When external DC voltage is applied to the electrolyte, the electronic conductivity of the electrodes drives the ions, electrolyte causing through oscillation reduction reaction. This process is known as Faradic process.
- ⇒ When the external ac voltage is applied a layer of one half cycle is oscillation of losses electrodes to its electrolyte solution, one more half cycle is undergone to reduction. Therefore the electrical energy is then converted into heat due to mobility of ions.

## Note:

- ⇒ Each electrode acts as a capacitor plate with the current decreasing the surface area.

## Liquid junction potential or other potential.



- ⇒ Liquid junction potential arises when two electrolyte solution of different chemical composition coming in contact because of unequal distribution of positive ion (cathion) & negative ion (anion) across the junction.
- ⇒ The speeds are governed by the concentration difference b/w the electrolyte since migration occurs from higher to lower concentration.

- Besides mobility is also a factor in determining the speed of the ion.
- ⇒ The function potential may be quite large in value.
- ⇒ The salt bridge is actually a concentrated electrolyte solution.
- ⇒ Salt bridge joins the two half cell electrolytes, saturated with  $\text{KCl}$ . Because of high concentration,  $\text{KCl}$  is used at salt bridge. Due to the high concentration level w.r.t. the half cell electrolyte concentration, there occurs a drop.
- ⇒ With a current flowing in the cell there occurs a drop. Ohm's law ( $V=IR$ ) therefore, the relation expressing the mechanism

$$\epsilon_{\text{thermodynamic}} = \epsilon_{\text{cathode}} - \epsilon_{\text{anode}}$$

$$\epsilon_{\text{cell}} = \epsilon_{\text{thermodynamic}} - IR$$

$$\boxed{\epsilon_{\text{cell}} = \epsilon_{\text{thermodynamic}} - \epsilon_{\text{cathode}} - \epsilon_{\text{anode}}}$$

(\*)

$$\boxed{\epsilon_{\text{cell}} = \epsilon_{\text{cathode}} - \epsilon_{\text{anode}} - IR.}$$

The cell potential. — Standard hydrogen electrode.

- ⇒ The potential of an electrochemical cell depends on the electrode potentials which are the characteristics of the half cell with the concerned electrodes & the effect of concentration of their product in the solution.

- ⇒ From thermodynamic consideration, the maximum work obtain from the cell having constant temperature and pressure depends on Gibbs free energy. A reaction is given by:

$$\Delta G = RT \ln B - RT \ln A$$

Let  $R$  = Gas constant

$T$  = Temperature

$A$  = Equilibrium constant for the reaction given by



$$A = \frac{[a^+][b^-]}{[ab]}$$

where A stands for acid, b stands for base  
& ab for activity.

⇒ The term B expressed as.

$$B = \frac{[a^+]_n [b^-]_n}{[ab]_n}$$

where n denotes instantaneous constant.

⇒ The amount of free energy depends on the cell potential  $E_c$ . is related to the free energy

$$\boxed{\begin{array}{l} E_c = F \\ \text{Gibbs free energy} \\ \Delta G = -n E_c F \end{array}}$$

where n = no. of equivalent of electricity, the electron associated with the oxidation & reduction process. Therefore the

∴ The cell potential  $E_{cell}^o$  is expressed as.

$$\boxed{E = E_c^o - \left[ \frac{RT}{nF} \right] \ln \frac{[a^+][b^-]}{[ab]}}$$

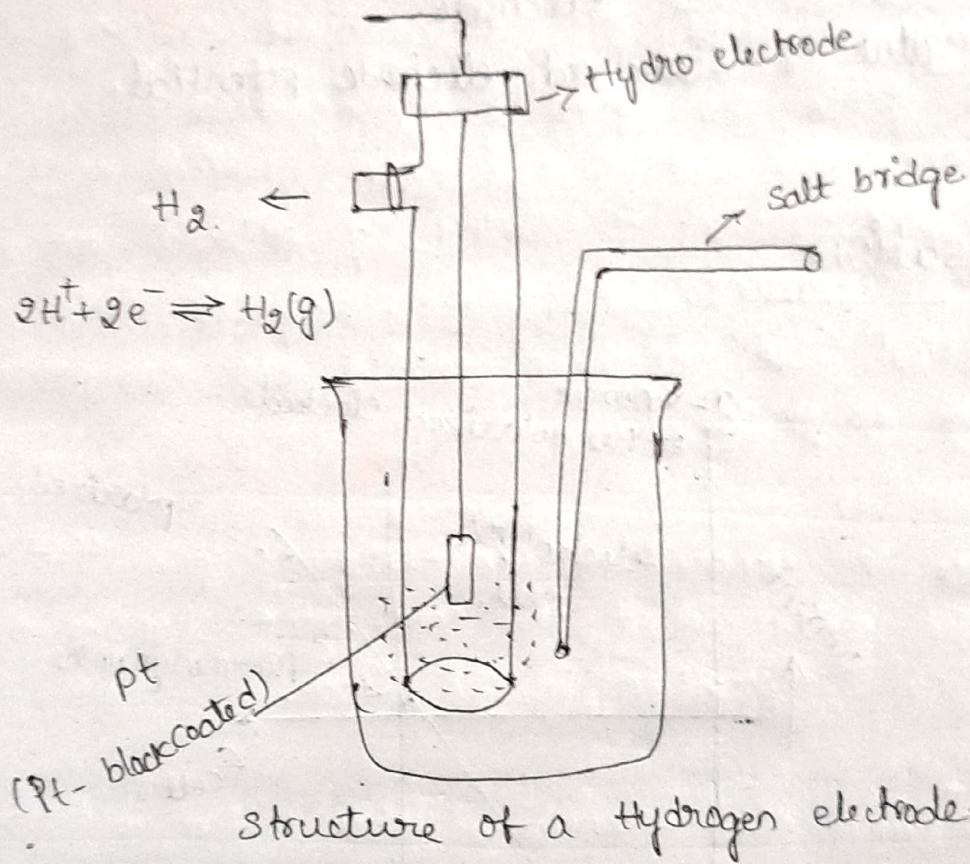
where  $E_c^o = \left[ \frac{RT}{nF} \right] \ln \frac{[a^+][b^-]}{[ab]}$

⇒ electrode potential basically form the electrical cell potenial. Therefore it is expressed as.

$$\boxed{E_c = E_{cathode} - E_{anode}}$$

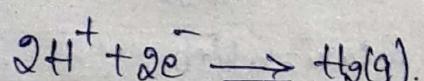
→ where  $E_{\text{cathode}}$  &  $E_{\text{anode}}$  are electrode potential for the corresponding half cell reaction therefore the Nernst equation is expressed as.

$$E = E_c - \frac{0.0159}{n} \ln \frac{[a_1^+] [a_2^+]}{[b_1^-] [b_2^-]}$$



→ the standard hydrogen electrode since the absolute potential of a half cell is not measurable. and it is the potential difference i.e. measured, a second half cell has to be formed. if this second half cell can be made as a common reference electrode this measured value would be available as a relative one but w.r.t. standard reference.

→ Standard Hydrogen electrode is not easily reproducible and instant conveniently produce secondary standard electrode are used to measure potentials.

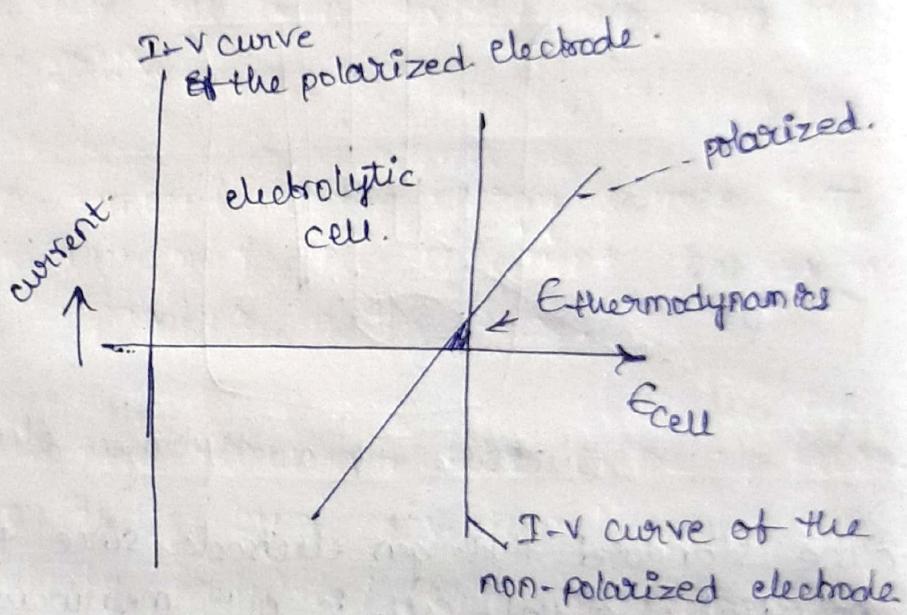


⇒ In above equation the platinum electrode uses a platinum coated with platinum block to provide a large surface area of reversible reaction with the Hydrogen solution near the electrode kept saturated with the gas.

⇒ For measurement of potential using standard hydrogen electrode two things are important

- \* polarities of the electrode
- \* the value of standard electrode potential.

## Polarisation



⇒ The polarization of the electrode potential being constant, in this case, the cell potential should be linearly related to the cell current.

⇒ But sometime this is not the situation the non-linearity that arises is due to mainly to polarization which is manifested as reduction of current

⇒ There are four types of polarization.

(i) Concentration polarization

(ii) Adsorption polarization.

- (iii) Absorption polarisation
- (iv) charge transfer polarisation

### (i) concentration polarisation

oxidation-reductions at the electrode surface can occur normally when the moment of electrons across the bulk of the electrolyte by mass transfer is normal. If non reaction rate decreases and also decrease the current. This is due to what is known as concentration polarisation.

### (ii) Reaction polarisation

If there is intermediate chemical reaction in any half cell producing oxidation or reduction that travels to electrode and which participate in electron transfer.

### (iii) Absorption polarisation

Sometimes the current is limited by process is such as absorption of the reactants etc hence this is called absorption polarisation.

### (iv) charge transfer polarisation.

charge transfer takes places from the electrode to oxidation from reduction to the electrode. The rate of charge transfer is reduced because of the cell. of the existence of a charge surface around the electrode.

## Fibre optic sensor

→ Fibre optic sensor could be classified as a separate group of sensors, where one consider for sensing different types of variables.

1. Temperature ↗

2. Liquid levels.

3. Fluid levels.

4. Magnetic field) (d) Micro Bend Sensing.

⇒ optical fibre are basically considered as communication channels, but it has been noticed that the optical transmission is effected by external parameters such as vibrations, Temperature, magnetic field.

⇒ the optical fibre has been divided into two groups.  
Active & passive.

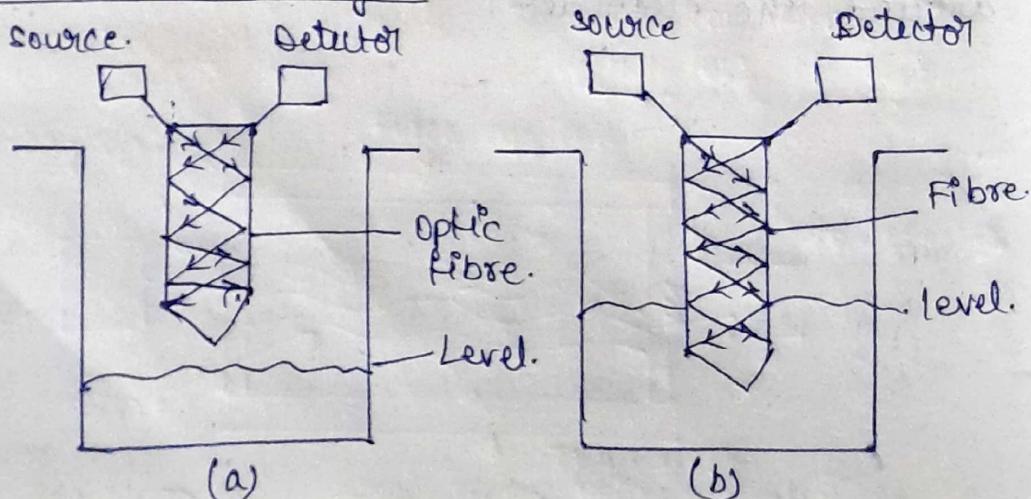
### Active:

The fibre is exposed to the energy source that effect the measurement and consequent changes in the optical propagation in the fibre.

### Passive:

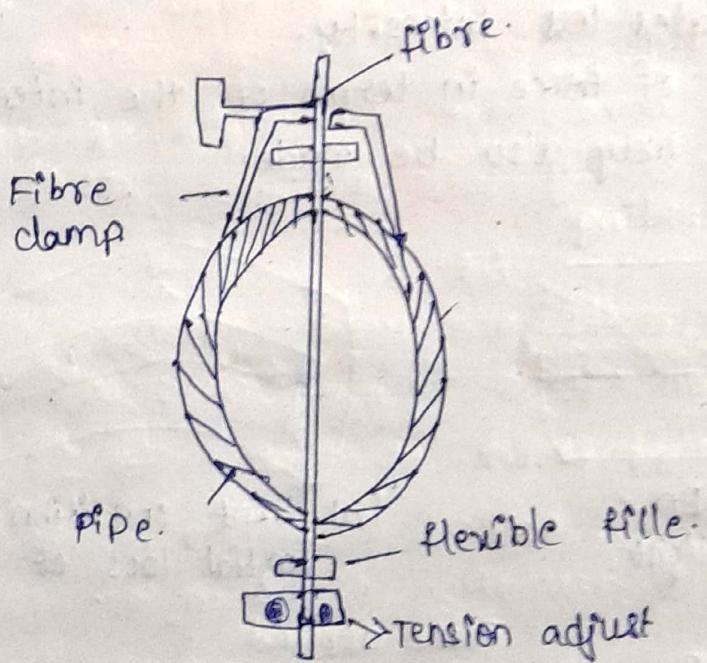
⇒ light transmitted through a fibre called P/Ip fibre is first modulated by a conventional optical sensor & this intensity modulated light is propagated through a second fibre called o/p fibre.

### Liquid level sensing



- ⇒ According to liquid level sensing the light propagates through a fibre by total internal reflection with appropriate (a) the light纤端 incidence angle is properly selected.
- ⇒ this is because the refractive index of air is <math>\neq</math> the fibre. that know no refractive index takes place.
- ⇒ the bottom end of the fibre is like prism so that with large difference in refractive index of the fibre
- ⇒ According to fig (a) when liquid level rises to cover the bottom of the fibre, the light reflect into the liquid & the detector fails to show any output.
- ⇒ According to fig(b) The single position level detected for discrete multi step detection. converting the entire height of the tank.
- ⇒ In this a step index multimode fibre is used & the fibre goes down carrying the light.

### Fluid flow Sensing



- ⇒ According to fluid flow sensing has been sensed by optical fibre mounted surroundingly in a pipe line through which is flows. because of the fibre mounted across the flow which in turn causes diameter of the pipe. & speed of the fluid range

and also affected by the vibration, the vibration frequency is proportional to fibre diameter. It is  $0.9 - 0.3 \text{ m/s}$  and also special detecting technique flow rate over range  $0.2 - 3 \text{ m/s}$ .

⇒ The fibre is kept under tension by a tension adjusting system and a fibre clamp.

### Micro bend sensors

⇒ Acoustic pressure sensing can be done by the micro bending of a multimode fibre. Figure (a) & figure (b) show how light loss occurs in microbends of a fibre.

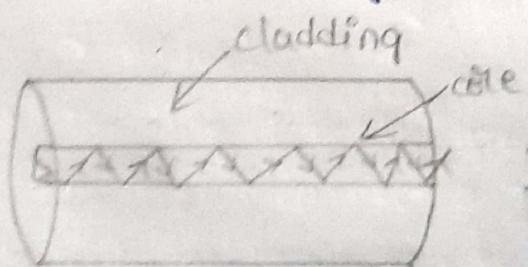
⇒ The technique is used utilized as shown in figure (c).

⇒ Optical fibre is placed in two corrugated plates to form a transducer as shown. as shown.

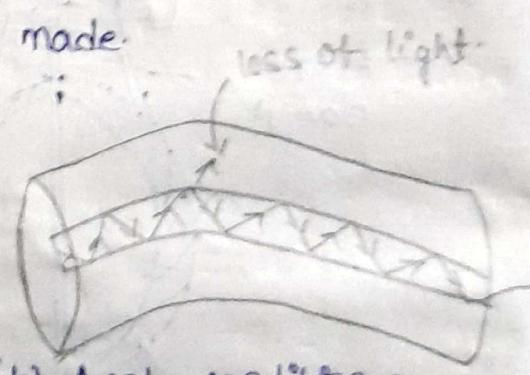
⇒ Applied force causes micro bending in the fibre.

⇒ Consequently, more light is lost and the receiver detector indicates less intensity.

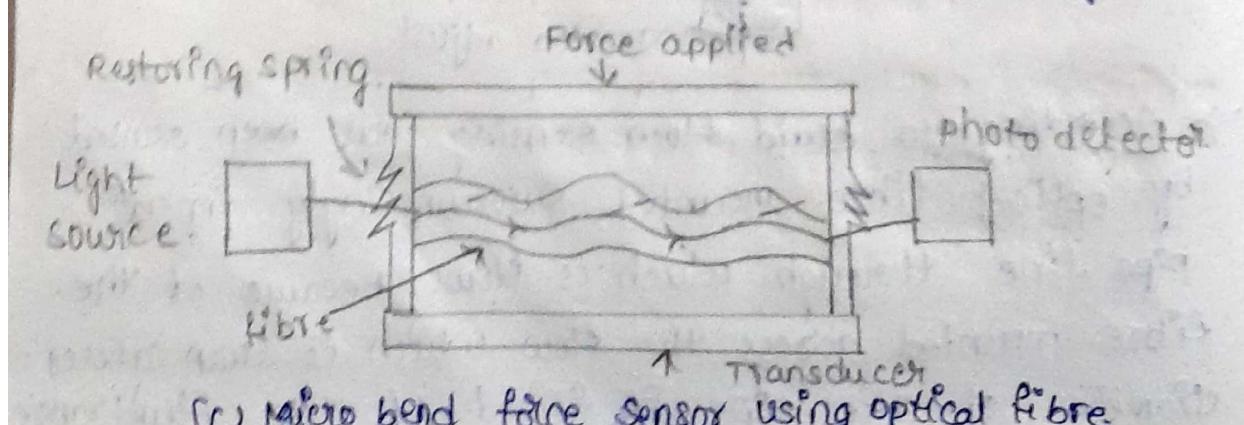
⇒ A calibration of force in terms of the intensity of detected light may also be made.



(a) Normal condition : no loss of light



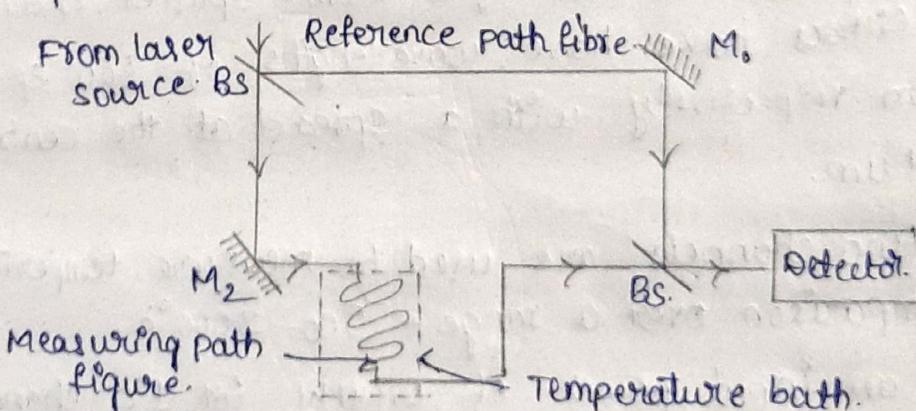
(b) Bent condition ; partial loss of light



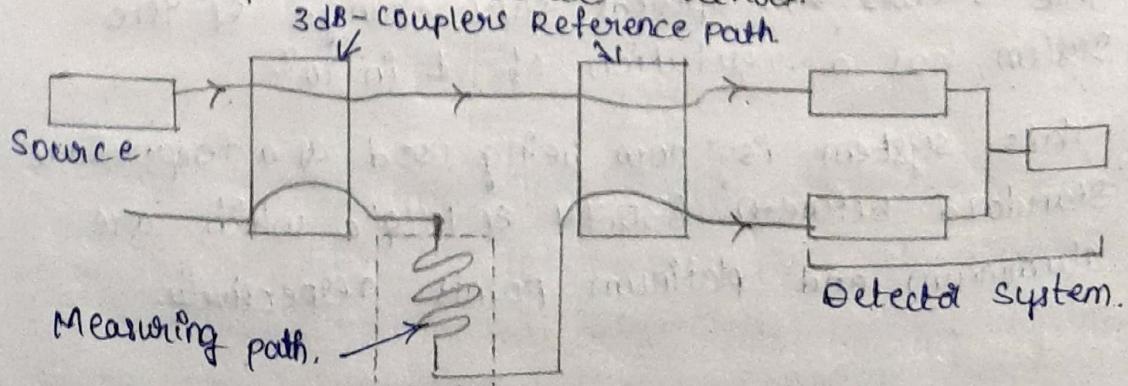
(c) Micro bend force sensor using optical fibre

## Temperature Sensors

- ⇒ When two identical optical fibres are used to propagate radiation from a source, say a laser source, and if one of these fibres is in a medium with temperature different than that of the other, the optical outputs from the two fibres would have a phase difference which is a function of the difference of temperature as mentioned.
- ⇒ This phase difference is due to optical path length variations in the two paths occurring due to temperature difference and is so small that it can only be measured by producing interference patterns.
- ⇒ Two schemes are given in figure (a) & (b) that use He-Ne laser as a source & the first one uses Mach-Zehnder interferometer as the detector while the second one uses a Michelson interferometer.
- ⇒ The beam-splitter (BS) and mirrors ( $M_1$ ) in the first case have been dispensed with using fibre couplers in the second.

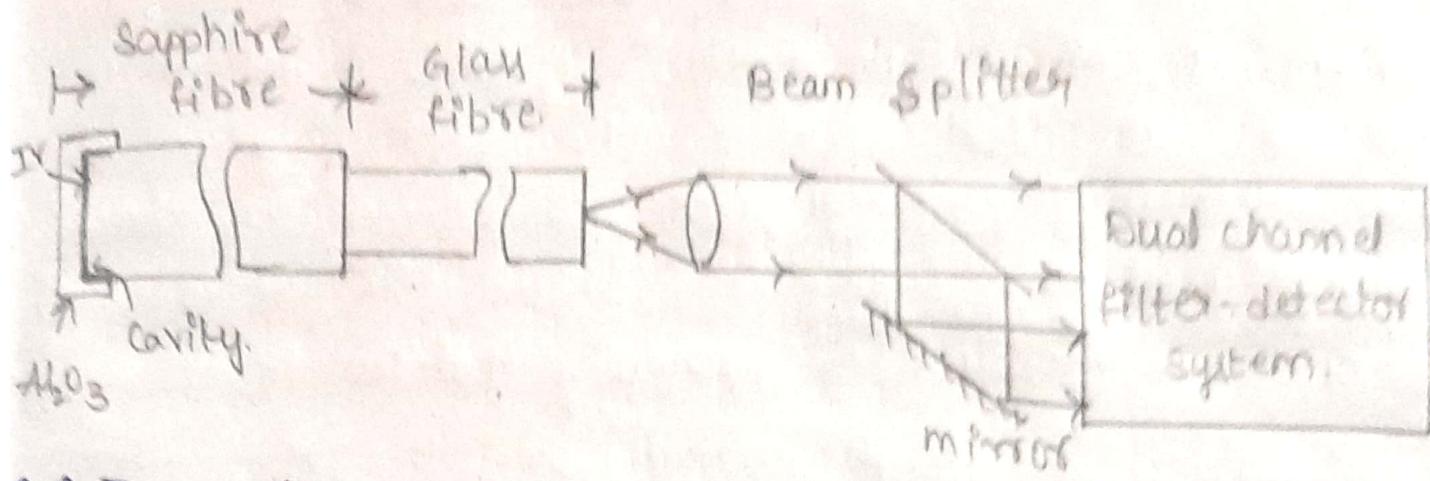


(a) phase difference method.



(b) technique avoiding beam splitter or mirror.

- ⇒ another optical fibre temperature sensor is used on the principle that a black body cavity changes radiance with varying temperature.
- ⇒ thus at the end of a bi fibre black body cavity is formed.
- ⇒ the fibre is a high temperature fibre, usually a sapphire fibre, of diameter 0.25 - 1.25 mm.
- ⇒ A thin film of iridium is sputtered onto the endsurface and a protective cover of Aluminium oxide ( $Al_2O_3$ ) is then provided. This measuring fibre has a length usually within 0.3m & not less than 5cm.
- ⇒ this propagates the radiation from the formed cavity which is being heated by the heat of the process.
- ⇒ At the propagation end, another fibre, a low temperature fibre made of glass about 0.6mm diameter is coupled that has a length usually within 10cm.
- ⇒ the detector system consists of one lens & two narrow band filters of close range middle wavelengths, two photomultiplier tubes in two measuring channels fed by a beam-splitter & a mirror.
- ⇒ The filters have wavelengths of 600 & 700nm respectively with a spread at the centre of 0.1nm.
- ⇒ The two channels are used to measure temperature by comparison over a range • 500 - 2000°C.
- ⇒ with an input power of 0.1mW for 1°C change there occurs ⇒ optical flux change & the system has a resolution of 1 in  $10^8$ .
- ⇒ This system is now being used as a temperature standard between 630.74 & 1769°C which are aluminium and platinum points respectively.



(a) Temperature sensor fibre black body cavity.